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CONFIRMATION NO. 5406

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SERIAL NUMBER 10/665,122	FILING DATE 09/22/2003  RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 2557-000163/US
<b>APPLICANTS</b>  Ja-Hum Ku, Sunnam-city, KOREA, REPUBLIC OF;  Chang-Won Lee, Seoul, KOREA, REPUBLIC OF; Seong-Jun Heo, Seoul, KOREA, REPUBLIC OF; Sun-Pil Youn, Seoul, KOREA, REPUBLIC OF; Sung-Man Kim, Seoul, KOREA, REPUBLIC OF;				
<b>** CONTINUING DATA *****</b> <div style="text-align: center;"><i>None WLL</i></div>				
<b>** FOREIGN APPLICATIONS *****</b> REPUBLIC OF KOREA 2002-57456 09/19/2002 <i>WLL</i>				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 12/11/2003</b>				
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>WLL</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 7	TOTAL CLAIMS 25
			INDEPENDENT CLAIMS 2	
<b>ADDRESS</b> 30593 HARNESS, DICKEY & PIERCE, P.L.C. P.O. BOX 8910 RESTON, VA 20195				
<b>TITLE</b> Methods of fabricating a semiconductor device having a metal gate pattern				
		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing )		